IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Young-Kwan Lee, et al.		
Serial No Pending	Filing Date: January 27, 2004		
Title of Application:	Antenna Structure For Inductively Coupled Plasma Generator		

Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

Information Disclosure Statement by Applicants

Dear Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (copies of the listed patents enclosed).

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U.S. Patent Documents							
Exam. Initials	Class/ Subclass.	Document No.		Date	Name		
	376/123	5,289,509		1994	Moeller		
Foreign Patent Documents							
Exam. Initials	Document No.		Date		Country		
TXL	1 079 671		2001	EP			
TXL	2000-323298		2000	JP (wi	th English abstract)		
TXL	2000-048998		2000	JP (wi	JP (with English abstract)		

The listed patents pertain in a general way to the subject matter of the application, but are not necessarily considered to be analogous prior art.

	Respectfully submitted,
January 27, 2004	A. J. Parke
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